

PATENT ASSIGNMENT

Electronic Version v1.1
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SUBMISSION TYPE:	NEW ASSIGNMENT																		
NATURE OF CONVEYANCE:	ASSIGNMENT																		
CONVEYING PARTY DATA																			
<table border="1"> <thead> <tr> <th>Name</th> <th>Execution Date</th> </tr> </thead> <tbody> <tr> <td>Byung Hee HONG</td> <td>01/23/2013</td> </tr> <tr> <td>Jong-Hyun AHN</td> <td>01/29/2013</td> </tr> <tr> <td>Ji Beom YOO</td> <td>01/26/2013</td> </tr> <tr> <td>Su Kang BAE</td> <td>01/30/2013</td> </tr> <tr> <td>Myung Hee JUNG</td> <td>01/23/2013</td> </tr> <tr> <td>Houk JANG</td> <td>01/29/2013</td> </tr> <tr> <td>Youngbin LEE</td> <td>01/29/2013</td> </tr> <tr> <td>Sang Jin KIM</td> <td>01/24/2013</td> </tr> </tbody> </table>		Name	Execution Date	Byung Hee HONG	01/23/2013	Jong-Hyun AHN	01/29/2013	Ji Beom YOO	01/26/2013	Su Kang BAE	01/30/2013	Myung Hee JUNG	01/23/2013	Houk JANG	01/29/2013	Youngbin LEE	01/29/2013	Sang Jin KIM	01/24/2013
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PROPERTY NUMBERS Total: 1																			
<table border="1"> <tr> <th>Property Type</th> <th>Number</th> </tr> <tr> <td>Application Number:</td> <td>13810144</td> </tr> </table>		Property Type	Number	Application Number:	13810144														
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Application Number:	13810144																		
CORRESPONDENCE DATA																			
Fax Number: 2023153758 <i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>																			

OP \$40.00 13810144

Phone: 202-429-0020
Email: info@nsiplaw.com
Correspondent Name: NSIP LAW
Address Line 1: P.O. Box 65745
Address Line 4: Washington, DISTRICT OF COLUMBIA 20035

ATTORNEY DOCKET NUMBER:	042088.0014
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NAME OF SUBMITTER:	Charles Y. Park
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Total Attachments: 12

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ASSIGNMENT

For valuable consideration, we,

HONG, Byung Hee	202, 115-43 Samseong-dong, Gangnam-gu, Seoul 135-090, Republic of Korea
AHN, Jong-Hyun	101-1602 Raemian Nobleclass Apt., Ingye-dong, Paldal-gu, Suwon-si, Gyeonggi-do 442-703, Republic of Korea
YOO, Ji Beom	Institute of Nanotechnology, Sungkyunkwan Univ., 300 Cheoncheon-dong, Jangan-gu, Suwon-si, Gyeonggi-do 440-746, Republic of Korea
BAE, Su Kang	83602, Research Complex 2, Sungkyunkwan Univ., 300 Cheoncheon-dong, Jangan-gu, Suwon-si, Gyeonggi-do 440-746, Republic of Korea
JUNG, Myung Hee	83602, Research Complex 2, Sungkyunkwan Univ., 300 Cheoncheon-dong, Jangan-gu, Suwon-si, Gyeonggi-do 440-746, Republic of Korea
JANG, Houk	301, 288-27 Yuljeon-dong, Jangan-gu, Suwon-si, Gyeonggi-do 440-825, Republic of Korea
LEE, Youngbin	83510, Research Complex 2, Sungkyunkwan Univ., 300 Cheoncheon-dong, Jangan-gu, Suwon-si, Gyeonggi-do 440-746, Republic of Korea
KIM, Sang Jin	83602, Research Complex 2, Sungkyunkwan Univ., 300 Cheoncheon-dong, Jangan-gu, Suwon-si, Gyeonggi-do 440-746, Republic of Korea

hereby assign to:

**SUNGKYUNKWAN UNIVERSITY FOUNDATION FOR
CORPORATE COLLABORATION** a Republic of Korea
corporation having principal executive offices or a place of
business at c/o Sungkyunkwan Univ., 300 Cheoncheon-dong,
Jangan-gu, Suwon-si, Gyeonggi-do 440-746, Republic of Korea,
and

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foundation having principal executive offices or a place of
business at 28 Sungju-dong, Seongsan-gu, Changwon-city,
Kyongsangnam-do 641-716, Republic of Korea,

Docket No. _____

and their successors and assigns (collectively hereinafter called "the Assignees"), the entire right, title and interest throughout the world in the inventions and improvements that are the subject of U.S. Patent Application Number 13/810,144 filed January 14, 2013 in the U.S. Patent & Trademark Office, signed by us and entitled:

METHOD FOR PRODUCING GRAPHENE AT A LOW TEMPERATURE, METHOD FOR DIRECT TRANSFER OF GRAPHENE USING SAME, AND GRAPHENE SHEET We authorize and request the attorneys appointed in said application to hereafter complete this Assignment by inserting above the application number and filing date of said application when known, and to correct any typographical errors that may be discovered in this Assignment; this Assignment including said application, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and we authorize the Assignees to apply in all countries in our name or in its own name for patents, utility models, design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements; and we agree for ourselves and our respective heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, Assignments, preliminary statements and other lawful documents as the Assignees may reasonably request to effectuate fully this Assignment.

IN TESTIMONY/WITNESS WHEREOF, we, the undersigned inventors (Assignors), intending to be legally bound, have hereto affixed our signatures.

This _____ day of _____, 2013

HONG, Byung Hee

This _____ day of _____, 2013

AHN, Jong-Hyun

This _____ day of _____, 2013

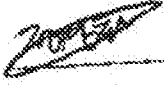
YOO, Ji Beom

Docket No. _____

This _____ day of _____, 2013

BAE, Su Kang

This 23 day of JUN, 2013



RUNG, Myung Hee

This _____ day of _____, 2013

JANG, Houk

This _____ day of _____, 2013

LEE, Youngbin

This _____ day of _____, 2013

KIM, Sang Jin

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AHN, Jong-Hyun	101-1602 Raemian Nobleclass Apt., Ingye-dong, Paldal-gu, Suwon-si, Gyeonggi-do 442-703, Republic of Korea
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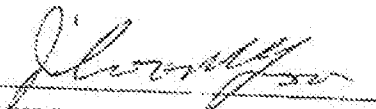
This _____ day of _____, 2013

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This _____ day of _____, 2013

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This 28 day of 1, 2013



YOO, Ji Beom

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This _____ day of _____, 2013

JANG, Houk

This 29th day of Jan, 2013



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This _____ day of _____, 2013

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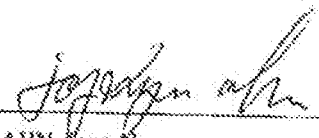
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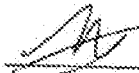
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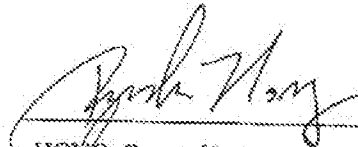
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This 23rd day of Jan, 2013



HONG, Byung Hee

This _____ day of _____, 2013

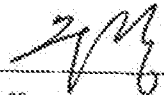
AHN, Jong-Hyun

This _____ day of _____, 2013

YOO, Ji Beom

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This 20 day of JAN, 2013



BAE, Su Kang

This _____ day of _____, 2013

JUNG, Myung Hee

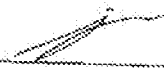
This _____ day of _____, 2013

JANG, Houk

This _____ day of _____, 2013

LEE, Youngbin

This 24 day of Jan, 2013



KIM, Sang Jin